

<b>Notice of References Cited</b>	Application/Control No. 10/593,669		Applicant(s)/Patent Under Reexamination HEIKKINEN ET AL.	
	Examiner CHUONG A. NGO		Art Unit 2617	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,742,668 A	04-1998	Pepe et al.	455/415
*	B	US-2002/0090963 A1	07-2002	Avalos et al.	455/466
*	C	US-2002/0111176 A1	08-2002	Roeder, G. R. Konrad	455/466
*	D	US-2002/0137530 A1	09-2002	Karve, Katyayini	455/466
*	E	US-2003/0139175 A1	07-2003	Kim, Jong-Hwan	455/419
*	F	US-2003/0194071 A1	10-2003	Ramian, Artoun	379/114.19
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
	V				
	W				
	X				

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.